



GAU 2814
#8K
2-8-00

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki ABE et al.

Group Art Unit: 2814

Application No.: 08/930,449

Examiner: S. Rao

Filed: September 30, 1997

Docket No.: JAO 39514

For: HIGH ENERGY SUPPLY APPARATUS, METHOD OF
FORMING CRYSTALLINE FILM AND METHOD OF
MANUFACTURING THIN FILM ELECTRONIC DEVICE

TC 2814
15-0461
JAO 39514
FEB 12 2000
USPTO
LCCM 15-0461-002-01

AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action mailed November 17, 1999, please amend the above-identified application as follows:

IN THE SPECIFICATION:

Please amend the Substitute Specification filed on September 30, 1997, as follows:

Page 6, line 33, change "invereson" to --inversion--.

Page 8, line 11, change "gammer" to --gamma--.

Page 10, line 20, after "air" insert --and--.

Page 14, line 23, after "advantage" insert --of--.

Page 15, line 31, change "Figure" to --Fig.--; and

line 34, change "Figure" to --Fig.--.

Page 16, line 1, change "Figure" to --Fig.--;

line 4, change "Figure" to --Fig.--;

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